

**Search Notes**

Application/Control No.

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Examiner

Sylvia R. MacArthur

Applicant(s)/Patent under  
Reexamination

KOBAYASHI, HIDEO

Art Unit

1716

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated search	3/11/2011	srm